



**ELECTRONIC COPY**

LG671444649  
Report verification at igi.org



December 28, 2024  
IGI Report Number **LG671444649**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **8.38 X 6.04 X 3.93 MM**  
**GRADING RESULTS**  
Carat Weight **2.07 CARATS**  
Color Grade **D**  
Clarity Grade **INTERNALLY FLAWLESS**

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**GRADING RESULTS**

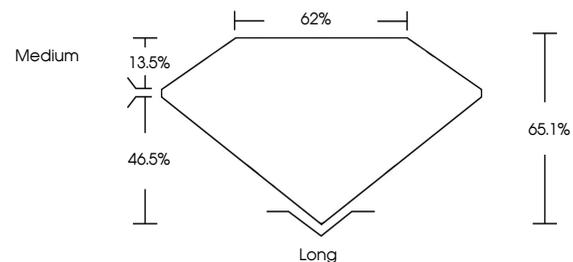
Carat Weight **2.07 CARATS**  
Color Grade **D**  
Clarity Grade **INTERNALLY FLAWLESS**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG671444649**

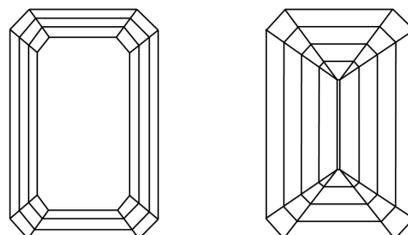
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

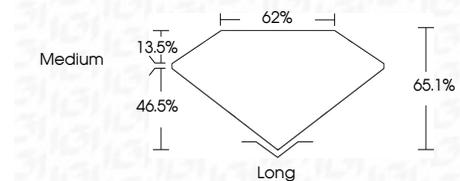
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



December 28, 2024  
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**EMERALD CUT**  
8.38 X 6.04 X 3.93 MM  
2.07 CARATS  
D  
Color Grade  
D  
Clarity Grade  
IF  
Depth  
65.1%  
Table  
62%  
Girdle  
Medium  
Culet  
Long  
Polish  
EXCELLENT  
Symmetry  
EXCELLENT  
Fluorescence  
NONE  
Inscription(s)  
IGI LG671444649  
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